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PTO/SB/08A (02-03)

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Complete if Known			
Application Number	10/716,006		
Filing Date	11/18/2003		
First Named Inventor	Mehregany		
Art Unit	1775		
Examiner Name	Archene A. Turner		
Attorney Docket Number	29438/04001		

				DOCUMENTS		
Examiner Ci Initials* No		Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant	
		Number-Kind Code ² (# Innown)			Figures Appear	
X)		US- 5,616,426	04-01-1997	Tenbover et al.		
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		FORE	IGN PATENT DOCU	JMENTS		
Examiner Initials*	Cite No. ¹	Foreign Patent Document Country Code ⁵ Number ⁴ "Kind Code ⁵ (# known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages Or Relevant Figures Appear	T ⁶
IR.		EP 0445 319 A1	09-11-1991	International Business Machines Corp.		
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Examiner Signature	Date Considered	12/05

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Substitute for form 1449/PTO		Complete if Known			
200201011	8 IOI IOIIII 14432F 10	•		Application Number	10/716,006
INFO	RMATIO	N DIS	CLOSURE	Filing Date	11/18/2003
STA	STATEMENT BY APPLICANT		First Named Inventor	Mehregany	
	ORMATION DISCLOSURE Filing ATEMENT BY APPLICANT (Use as many sheets as necessary)	Art Unit	1775		
(Use as many sneets as necessary)		Examiner Name	Archene A. Turner		
Sheet	2	of	2	Attomey Docket Number	29438/04001

Examiner Initials*	Cite No. ¹	NON PATENT LITERATURE DOCUMENTS Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.			
A		Hwang, J-D et al, "Epitaxial Growth and Electrical Characteristics of Beta-SiC on Si by Low-Pressure Rapid Thermal Chemical Vapor Deposition." Japanese Journal of Applied Physics. Tokyo, JP, vol. 34, no. 3, Part 1, March 1995 (1995-03), pgs. 1447-1450. XP-000703002			
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A		Search Report for PCT/US2004/037064, published 9/12/2005.			
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